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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN the application of
KOROLIK et al.

Application No.: 10/817,398

Filed: April 1, 2004

For: CONTROLS OF AMBIENT
ENVIRONMENT DURING WAFER DRYING
USING PROXIMITY HEAD

)
) Group Art Unit: 1746

)
) Examiner: Unassigned

)
) Docket No.: LAM2P467

)
) Date: March 6, 2007

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 6, 2007.

Signed: _____

Sylvia Castillo

Sylvia Castillo

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Kindly amend the above-identified application as follows:

The **Amendments to the Specification** are identified in the Marked-Up Specification.

Applicant's **Remarks** being on page 2 of this paper.